



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of
Lu, et. al.

Group Art Unit: 2813

Application No. 10/800,998

Examiner: Chen

Filed: March 16, 2004

Att. Docket No.: 95153DIV

For: METHOD FOR FABRICATING SILICON-ON-INSULATOR MATERIAL

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January 25, 2006

**AMENDMENT AND RESPONSE
AND REQUEST FOR CONTINUED EXAMINATION**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the pending Final Office Action mailed October 31, 2005,
please amend the above-identified application as follows: